Notice of References Cited Application/Control No. 09/866,656 Examiner Mike Qi Applicant(s)/Patent Under Reexamination PARK ET AL. Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-2003/0189679 A1	10-2003	Choi et al.	349/46
	В	US-6,621,547 B2	09-2003	Kang, Sin-Gu	349/151
	C	US-6,639,589 B1	10-2003	Kim et al	345/206
	D	US-2004/0041779 A1	03-2004	Kang	345/100
	Ε	US-5,463,230	10-1995	Negoto et al	257/66
	F	US-			
	G	US-			
	Н	US-			
·	1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U						
	V						
	w						
	х						

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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